

<b>FORM 1449*</b> <b>INFORMATION DISCLOSURE STATEMENT</b> <b>IN AN APPLICATION</b> <b>(Use several sheets if necessary)</b>	Docket Number: <b>KOLS.052PA</b>	Application Number: <b>unassigned 10/665869</b>
	Applicant: <b>TOKKONEN</b>	<b>2629</b>
	Filing Date: <b>9/19/2003</b>	Group Art Unit: <b>unassigned</b>

Duplicated

EXAMINER	/Kevin M. Nguyen/	DATE CONSIDERED	08/21/2006
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.

<p style="text-align: center;"><b>SEP 27 2004</b></p> <p><b>U.S. PATENT AND TRADEMARK OFFICE</b></p> <p><b>FORM 1449*</b></p> <p><b>SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT</b></p> <p><b>IN AN APPLICATION</b></p> <p>(Use several sheets if necessary)</p>	Docket Number:	Application Number:
	KOLS.052PA	10/665,869
	Applicant: Tokkonen	
Filing Date: 09/19/2003	Group Art Unit: 2032 2629	

## **U.S. PATENT DOCUMENTS**

## **FOREIGN PATENT DOCUMENTS**

	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
KMN	WO 01/77792 A2	18.10.2001	PCT	—	—	X	
KMN	WO 99/21073	29.04.1999	PCT	—	—	X	

**OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)**

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